

Divisional of U.S. Appl. No.: 09/963,382
Preliminary Amendment dated: October 1, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : MATSUNAGA et al.
Appl. No. : Divisional of 09/963,382
Filed : This application filed herewith: October 1, 2003
Title : METHOD AND APPARATUS FOR PROCESSING
SUBSTRATES AND METHOD FOR MANUFACTURING
A SEMICONDUCTOR DEVICE

TC/A.U. : 2812
Examiner : W. Lindsay

Docket No.: : MATS3003D/REF
Customer No: : 23364

PRELIMINARY AMENDMENT
AND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to an examination on the merits, please amend the above identified application as follows:

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 7 of this paper.